

RECEIVED
CENTRAL FAX CENTER

001

NOV 18 2004

**Fax transmission from:**

U.S. Naval Research Laboratory
Associate Counsel Intellectual Property, Code 1008.2
4555 Overlook Avenue, SW
Washington, DC 20375-5325

From: Joe Grunkemeyer

Phone: (202) 404-1556

Fax: (202) 404-7380

Date: 11/18/2004**To:** Examiner Ling Siu Choi

Art Unit 1713

Fax: (703) 872-9306

Cover Sheet + 8 Pages

Message:

RE: Patent Application No.: 10/006,385

Filed: 12/10/2001

Inventor: Keller et al.

Docket No.: NC 82,591

Amendment after Final Rejection – 8 pages

The information contained in this facsimile may be client confidential, and may also be attorney privileged. The information is intended only for the use of the individual or entity to whom it is addressed. If you are not the intended recipient, you are hereby notified that any use, distribution, or copying of this transmission is prohibited. If you have received this facsimile in error, please notify us immediately by telephone for instructions. Thank you.

PATENT APPLICATION
Docket No.: NC 82,591

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

RECEIVED
CENTRAL FAX CENTER
NOV 18 2004

In the application of: Keller et al.

Serial No.: 10/006,385

Filed: 12/10/2001

For: METAL NANOPARTICLE THERMOSET AND CARBON COMPOSITIONS FROM
MIXTURES OF METALLOCENE-AROMATIC-ACETYLENE COMPOUNDS

Examiner: Choi, Ling Siu

Art Group Unit: 1713

Honorable Commissioner of Patents

PO Box 1450

Alexandria, VA 22313-1450

November 18, 2004

AMENDMENT IN RESPONSE TO FINAL REJECTION

Sir:

In response to the Office action of 11/01/2004, setting a three month shortened statutory period of reply, please amend the above-identified application as follows.

Amendments to the Claims are reflected in the listing of claims, which begins on page 2 of this paper.

Remarks begin on page 7 of this paper.

CERTIFICATE OF FACSIMILE TRANSMISSION

I certify that this correspondence is being facsimile transmitted to the US Patent and Trademark Office on the date shown below.

11/18/04
Date

Joseph T. Grunkemeyer
Joseph T. Grunkemeyer